

IAP12 Rec'd PCT/PTO 28 APR 2006

PTO/SB/08a (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

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Substitute for form 1449A/PTO

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

**(Use as many sheets as necessary)**

Sheet	1	of	2
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**Complete if Known**

Application Number	10/577377
Filing Date	
First Named Inventor	KATSOULIS
Art Unit	1791
Examiner Name	Saeed M. Huda
Attorney Docket Number	DC5184 PCT1

## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

Examiner Signature	/Saeed Huda/	Date Considered	02/17/2009
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Substitute for form 1449B/PTO  <h2 style="text-align: center;">INFORMATION DISCLOSURE STATEMENT BY APPLICANT</h2> <p style="text-align: center;">(Use as many sheets as necessary)</p>				<b>Complete if Known</b>	
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Sheet	2	of	2
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		JP 11-059094, Published 03-02-1999, Patent Abstracts of Japan.	
		JP 06-210740, Published 08-02-1994, Patent Abstracts of Japan.	
		JP 05-338091, Published 12-21-1993, Patent Abstracts of Japan.	
		American Vacuum Society, "Embossing of polymers using a thermosetting polymer mold made by soft lithography," Rubo Xing, Zhe Wange and Yanchun Han, Jul/Aug 2003, pg. 1318-1322.	
		Optical Fiber and Planar Waveguide Technology II, "High Performance Polymer Waveguide Devices via Low Cost Direct Photolithography Process," J.Wang, P.Shustack, S.Garner, Vol. 4904, 2002, pg. 129-138.	
		The Royal Society of Chemistry, "Microfluidic devices fabricated in poly(methyl methacrylate) using hot-embossing...", S. Qi, et. al., Lab Chip 2002, vol. 2, pg. 88-95.	
		Lithographic and Micromaching Techniques..., "Fabrication of Diffractive Optical Elements on Si Chip by an Imprint Lithography using Non-Symmetrical Silicon Mold," Hirai, et. al., vol. 4440, 2001, pg. 228-237.	
		Emerging Lithographic Technologies VI, "Performance of 4" Wafer-Scale Thermoset Working Stamps in Hot Embossing Lithography," Roose, et. al., Vol 4688, 2002, pg. 232-239.	
		Microelectronic Engineering, "Chemical nano-patterning using hot embossing lithography," H. Schiff, et. al., vol. 61-62, 2002, pg. 423-428.	

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